

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2818
Ritsuko KAWASAKI et al.) Examiner: D. Vu
Serial No. 09/988,389)
Filed: November 19, 2001)
For: LASER IRRADIATION METHOD AND)
METHOD OF MANUFACTURING A)
SEMICONDUCTOR DEVICE)

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INFORMATION DISCLOSURE STATEMENT

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Dear Sir:


In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The attached references were cited in an Office Action by the Japanese Patent Office in counterpart Japanese application.

U.S. Patent Nos. 6,393,042 and 6,818,568 and U.S. Patent Publication No. 2002/0146873 are in the family of JP 2000-323428. These U.S. patents and publications were not directly cited by the Japanese Patent Office, but are submitted herewith for consideration by the Examiner.

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

Respectfully submitted,


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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/988,389
				Filing Date	November 19, 2001
				First Named Inventor	Ritsuko KAWASAKI et al.
				Group Art Unit	2818
				Examiner Name	David Vu
Sheet	1	of	1	Attorney Docket Number	0756-2393

U.S. PATENT DOCUMENTS						
Examiner Initials ²	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ³ (if known)			
		6,393,042		Tanaka	05/21/2002	
		6,818,568		Tanaka	11/16/2004	
		2002/0146873		Tanaka	10/10/2002	

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FOREIGN PATENT DOCUMENTS								
Examiner Initials ²	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
		JP	59-099434			07/05/1984		None
		JP	62-007691			01/14/1987		Abst.
		JP	2000-323428			11/24/2000		Abst.
		JP	10-178178			06/30/1998		Abst.
		JP	2001-284250			10/12/2001		Abst.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ²	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

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